




<p><b>Searched</b></p> 	<p>Application/Control No.</p> <p>10648791</p>	<p>Applicant(s)/Patent Under Reexamination</p> <p>DAMM ET AL.</p>
	<p>Examiner</p> <p>Wong, Joseph D</p>	<p>Art Unit</p> <p>2100</p>

Class	Sub Class	Date	Examiner
707	102	3/21/2006	JDW
709	225	3/22/2006	JDW
U.S. Patent and Trademark Office			Part of Paper No.: 20060317

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<b>Interference Searched</b>  	Application/Control No.  10648791	Applicant(s)/Patent Under Reexamination  DAMM ET AL.
	Examiner Wong, Joseph D	Art Unit 2100

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<b>Search Notes</b>  	Application/Control No.  10648791	Applicant(s)/Patent Under Reexamination  DAMM ET AL.
	Examiner Wong, Joseph D	Art Unit 2100

Notes	Date	Examiner
IEEE Explore, ACM Database, Amazon.com, IBM Technical Database, IETF.org	5/1/2006	JDW
PLUS Search	3/22/2006	JDW
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